## 

E. H. Bernhardi,<sup>1,\*</sup> H. A.G.M. van Wolferen,<sup>2</sup> L. Agazzi,<sup>1</sup> M. R.H. Khan,<sup>3</sup> C. G.H. Roeloffzen,<sup>3</sup> K. Wörhoff,<sup>1</sup> M. Pollnau,<sup>1</sup> and R. M. de Ridder<sup>1</sup>

<sup>1</sup>Integrated Optical MicroSystems Group, MESA+ Institute for Nanotechnology, University of Twente, P.O. Box 217, 7500 AE Enschede, The Netherlands

<sup>2</sup>Transducers Science and Technology Group, MESA+ Institute for Nanotechnology, University of Twente, P.O. Box 217, 7500 AE Enschede, The Netherlands

<sup>3</sup>Telecommunication Engineering Group, Faculty of Electrical Engineering, Mathematics and Computer Science, University of Twente, P.O. Box 217, 7500 AE Enschede, The Netherlands \*Corresponding author: E.H.Bernhardi@ewi.utwente.nl

Received March 30, 2010; revised June 21, 2010; accepted June 23, 2010; posted June 28, 2010 (Doc. ID 126222); published July 8, 2010

We report the realization and performance of a distributed feedback channel waveguide laser in erbium-doped aluminum oxide on a standard thermally oxidized silicon substrate. The diode-pumped continuous-wave laser demonstrated a threshold of 2.2 mW absorbed pump power and a maximum output power of more than 3 mW with a slope efficiency of 41.3% versus absorbed pump power. Single-longitudinal-mode and single-polarization operation was achieved with an emission linewidth of 1.70  $\pm$  0.58 kHz (corresponding to a *Q* factor of 1.14 × 10<sup>11</sup>), which was centered at a wavelength of 1545.2 nm. © 2010 Optical Society of America *OCIS codes:* 130.0130, 140.3570, 140.3490, 140.3500.